



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 27, 2026	
IGI Report Number	LG808606174
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND ROSE CUT
Measurements	6.96 - 6.93 X 2.51 MM

GRADING RESULTS

Carat Weight	1.15 CARAT
Color Grade	D
Clarity Grade	VVS 2

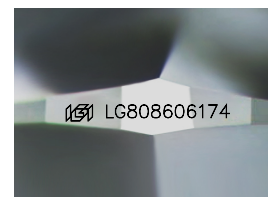
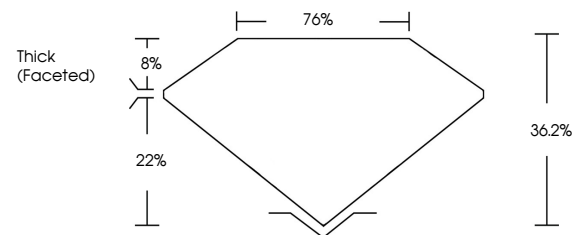
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

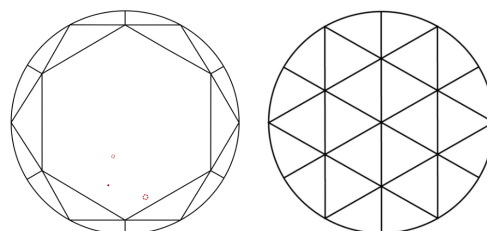
LG808606174
Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

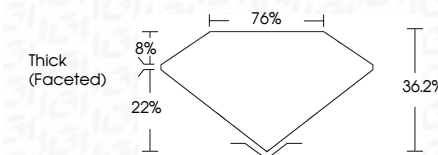
D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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July 27, 2026
GI Report No LG808606174
ROUND ROSE, CT

6.96 - 6.93 X 2.51 MM	1.15 CARAT
Carat Weight	D
Color Grade	VVS 2
Clarity Grade	76%
Depth	76%
Table	Thick (faceted)
Girdle	
Culet	
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE

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created by Chemical Vapor Deposition
(CVD) growth process.